PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of

Makoto HIRANO et al. Group Art Unit: 1792

Application No.: 10/570,156 Examiner: N. FORD

Filed: March 27, 2006 Docket No.: 127194

For: SUBSTRATE TREATMENT EQUIPMENT MAIL STOP RCE

AND MANUFACTURING METHOD OF

SUBSTRATE

LARGE ENTITY REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

Applicant(s) further request(s) entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. <u>216695</u> in the amount of \boxtimes \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

Registration No. 27,075

Rodney H. Rothwell, Jr. Registration No. 60,728

JAO:RHR/nlp

Date: March 27, 2009

OLIFF & BERRIDGE, PLC P.O. Box 320850 Alexandria, Virginia 22320-4850 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

03/30/2009 AWONDAF1 00000096 10570156

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